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ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

Title of Invention	SUPPRESSION OF LOCALIZED METAL PRECIPITATE FORMATION AND CORRESPONDING METALLIZATION DEPLETION IN SEMICONDUCTOR PROCESSING						
<p>Application Number : 10/708, 486</p> <p>Confirmation Number:</p> <p>First Named Applicant: Jonathan Chapple-Sokol</p> <p>Attorney Docket Number: BUR920040018US1</p> <p>Art Unit: 2823</p> <p>Examiner: B. KEBEDU</p> <p>Search string: (6596637 or 6319833 or 6197690 or 6177349).pn</p>							
US Patent Documents							
Note: Applicant is not required to submit a paper copy of cited US Patent Documents							
init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
BU	1	6596637	2003-07-22	Schonauer et al			
BU	2	6319833	2001-11-20	Schonauer et al			
BU	3	6197690	2001-03-06	Schonauer et al			
BU	4	6177349	2001-01-23	Schonauer et al			
Signature							
Examiner Name				Date			
B. KEBEDU				3/17/2006			